



(JRW)

Docket No.: 1568.1065

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Jae-Bon KOO, et al

Serial No. 10/624,636

Group Art Unit: 2813

Confirmation No. 6893

Filed: July 23, 2003

Examiner: Craig Thompson

For: CRYSTALLIZATION METHOD OF SILICON THIN FILM, THIN FILM TRANSISTOR  
MANUFACTURED USING THE METHOD, AND FLAT PANEL DISPLAY INCLUDING  
THE THIN FILM TRANSISTOR

**LETTER TO THE EXAMINER REQUESTING RECOGNITION AND ENTRY OF PREVIOUSLY  
FILED CHANGE IN POWER OF ATTORNEY AND CORRESPONDENCE ADDRESS**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

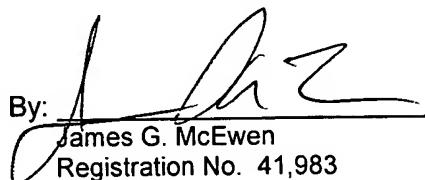
In accordance with the Power of Attorney filed on January 31, 2005, it is respectfully submitted that the attorneys of Stein, McEwen, & Bui, LLP, customer number 49,455, are associated with the instant application and all prior powers of attorney have been revoked.

Please direct all correspondence to the address associated with customer number 49,455, which is presently as follows:

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Respectfully submitted,

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Date: May 10, 2005